

	Application No.	Applicant(s)	
Notice of Allowability	10/750,470	KANG, HYO-CHEON	
	Examiner	Art Unit	·
	Lee, Calvin	2825	
The MAILING DATE of this communicate. All claims being allowable, PROSECUTION ON THE ME herewith (or previously mailed), a Notice of Allowance (PNOTICE OF ALLOWABILITY IS NOT A GRANT OF PA of the Office or upon petition by the applicant. See 37 Cl	RITS IS (OR REMAINS) CLOSED in TOL-85) or other appropriate commu TENT RIGHTS. This application is s	this application. If not included in this application will be mailed in due c	d ourse. THIS
1. \boxtimes This communication is responsive to <u>Election date</u>	<u>ed 12/10/04</u> .		
2. X The allowed claim(s) is/are 1-18 and 23-26.			
3. 🗵 The drawings filed on 31 December 2003 are according to the drawings filed on 31 December 2003	epted by the Examiner.		
4. Acknowledgment is made of a claim for foreign p a) All b) Some* c) None of the: 1. Certified copies of the priority docume 2. Certified copies of the priority docume 3. Copies of the certified copies of the p International Bureau (PCT Rule 17.2() * Certified copies not received:	ents have been received. ents have been received in Applicatio riority documents have been received	n No	on from the
Applicant has THREE MONTHS FROM THE "MAILING noted below. Failure to timely comply will result in ABATHIS THREE-MONTH PERIOD IS NOT EXTENDABLE	NDONMENT of this application.	a reply complying with the requ	uirements
5. A SUBSTITUTE OATH OR DECLARATION must INFORMAL PATENT APPLICATION (PTO-152) w			OTICE OF
 CORRECTED DRAWINGS (as "replacement sheet (a) ☐ including changes required by the Notice of D 1) ☐ hereto or 2) ☐ to Paper No./Mail Date (b) ☐ including changes required by the attached Expaper No./Mail Date Identifying indicia such as the application number (see each sheet. Replacement sheet(s) should be labeled as 	raftsperson's Patent Drawing Review re xaminer's Amendment / Comment or 37 CFR 1.84(c)) should be written on th	in the Office action of e drawings in the front (not the l	oack) of
7. DEPOSIT OF and/or INFORMATION about the attached Examiner's comment regarding REQUIR			ote the
 Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PT 3. Information Disclosure Statements (PTO-1449 or P Paper No./Mail Date 12/31/03 4. Examiner's Comment Regarding Requirement for Double of Biological Material 	O-948) 6. ☐ Interview Su Paper No./I TO/SB/08), 7. ☒ Examiner's	formal Patent Application (PTO ummary (PTO-413), Mail Date Amendment/Comment Statement of Reasons for Allov	·
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Application No: 10/750,470

Docket No: 2522-041

Hyo-Cheon KANG

OFFICE ACTION

Examiner's Amendment

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312

CLAIMS: Canceled non-elected claims 19-22 (without traverse dated 12/10/04).

Allowable Subject Matter

2. Claims 1-18 and 23-26 are allowed. Following is the statement reason for allowance:

The closest prior art, US 6,091,249 to *Talbot et al* disclose defects of a wafer using electron beams by instantly charging a wafer region. However, due to the insufficient of charge, an electrical defect generated on the surface of the wafer may not be detected [Fig. 6 and col. 8]; US 6,384,909 to *Tomita et al* discloses a method of inspecting multi-layer structures using a pair of oppositely and inclinedly directed laser beams [Fig. 1 and col. 3]; and lastly US 6,586,952 to *Nozoe et al* discloses to irradiate an electron beam to a wafer by a plurality of times to detect a difference in charge in the rearward bias [Figs. 1-2 and col. 7]. None of the cited arts discloses, *inter alia*, irradiating a first electron beam to charge an area of a wafer, a second electron beam onto an inspection region to inspect the region, and a third electron beam onto another area to discharge charges accumulated on the area.

3. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance.

Any inquiry concerning this communication from the Examiner should be directed to *Calvin Lee* at (571) 272-1896 from 7:00 to 5:00 (Mo-Th). If attempts to reach the examiner are unsuccessful, Art Unit 2825's Supervisory Patent Examiner *Matthew Smith* can be reached at (571) 272-1907. Any inquiry relating to the status of this application should be directed to the Group receptionist whose telephone number is (703) 308-0596. The central fax number is (703) 872-9306 for all communications to be entered (e.g., amendments, remarks, IDS, etc.)

CL

January 6, 2005

MATTHEW SMITH SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800